

Request for Tenders under Open (OJEU) Procedure for the Supply, Delivery and Installation of a Broad Ion Beam Milling System for SP&S for the Tyndall National Institute, UCC

Buyer: University College Cork (UCC)

Description:

The Specialty Products & Services Group (SP&S) at Tyndall National Institute, UCC, fabricate a wide variety of Semiconductor devices, ranging from traditional Silicon microelectronics and Silicon MEMS to III-V photonic devices. In addition, SP&S provide an extensive array of analysis services in all types of electronic devices and packages to internal and external customers. The Electron Microscopy and Analysis Facility (EMAF) within SP&S utilise a wide range of SEM, TEM and FIB equipment as part of these analysis services. We wish to extend our capability in the area of sample preparation by purchasing a fully functional Broad Ion Beam (BIB) milling system with an ancillary mechanical polishing system which will allow us to bridge a sample cross-section preparation gap between our existing plasma FIB and mechanical methods

Country:

Ireland

Published date:

Apr 06 2022

Deadline:

May 10 2022

CPVs:

39300000 - Miscellaneous equipment

73110000 - Research services

73111000 - Research laboratory services

38000000 - Laboratory, optical and precision equipments (excl. glasses)

Contact:

Wella Ziad

URL:

<http://www.ucc.ie>

Link:

[Link to original](#)

×

Please register

Registering is free and only takes a moment.

[Register](#)

[Login](#)

Open Contracts ID:
ocds-0c46vo-0117-211116

Saved on:
Apr 07 2022

Source ID:
211116

OCDS JSON:

<https://openopps.com/tenders/request-for-tenders-under-open-ojeu-procedure-for-the-supply-delivery-and-installation-of-a-broad-ion-beam-milling-system-for-sp-s-for-the-tyndall-national-institute-ucc/ocds-0c46vo-0117-211116?format=json>
